

Notice of References Cited	Application/Control No. 10/604,717	Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner Richard H Kim	Art Unit 2871	Page 1 of 1

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	B	US-5,983,543	11-1999	Hillstrom, David U.	40/574
	C	US-2002/0154474 a1	10-2002	Merz et al.	361/683
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NON-PATENT DOCUMENTS

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